



Attorney Docket No.: SAM-0465
Application Serial No.: 10/685,738
Reply to Office Action of: June 20, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyung-soo Kim, *et al.* Examiner: Chen, Kin Chan
Serial No.: 10/685,738 Group Art Unit: 1765
Filing Date: October 15, 2003
Title: METHOD FOR MANUFACTURING MULTI-THICKNESS GATE
DIELECTRIC LAYER OF SEMICONDUCTOR DEVICE

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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AMENDMENT AFTER FINAL

Sir:

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The following is in response to the Office Action dated June 20, 2006, and is filed within the shortened statutory period of three months. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.